

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kenji YOSHIDA, et al.

GAU:

SERIAL NO: New Application

EXAMINER:

FILED: Herewith

FOR: METHOD OF ACCELERATING TEST OF SEMICONDUCTOR DEVICE

REQUEST FOR PRIORITY

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

☐ Full benefit of the filing date of U.S. Application Serial Number _____, filed _____, is claimed pursuant to the provisions of 35 U.S.C. §120.

☐ Full benefit of the filing date(s) of U.S. Provisional Application(s) is claimed pursuant to the provisions of 35 U.S.C. §119(e): Application No. _____ Date Filed _____

☒ Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of 35 U.S.C. §119, as noted below.

In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:

COUNTRY

Japan

APPLICATION NUMBER

2002-238032

MONTH/DAY/YEAR

August 19, 2002

Certified copies of the corresponding Convention Application(s)

☒ are submitted herewith

☐ will be submitted prior to payment of the Final Fee

☐ were filed in prior application Serial No. _____ filed _____

☐ were submitted to the International Bureau in PCT Application Number _____
Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.

☐ (A) Application Serial No.(s) were filed in prior application Serial No. _____ filed _____; and

☐ (B) Application Serial No.(s) _____

☐ are submitted herewith

☐ will be submitted prior to payment of the Final Fee

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland
Registration Number 21,124



22850